

<b>Notice of References Cited</b>	Application/Control No. 10/785,617	Applicant(s)/Patent Under Reexamination LOOK, CHRISTOPHER M.	
	Examiner Danny Wai Lun Leung	Art Unit 2613	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,076,163 B2	07-2006	Kinoshita et al.	398/19
*	B	US-6,504,969 B1	01-2003	Tsao et al.	385/24
*	C	US-5,515,361 A	05-1996	Li et al.	370/222
*	D	US-6,417,944 B1	07-2002	Lahat et al.	398/79
*	E	US-6,826,368 B1	11-2004	Koren et al.	398/50
*	F	US-6,369,926 B1	04-2002	Lyu et al.	398/95
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.